## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Application Inventor:

Jeffrey W. Carr

Appln. No.:

10/002,483

Confirm. No.: 2209 Filed:

November 1, 2001 Title: METHOD FOR ATMOSPHERIC PRESSURE REACTIVE

ATOM PLASMA PROCESSING FOR SURFACE

**MODIFICATION** 

PATENT APPLICATION

Art Unit:

1763

Examiner:

Allan W. Olsen

Customer No. 23910

## **CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8**

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Signature Date: 2/11/2005

## RESPONSE B TO OFFICE ACTION UNDER 37 C.F.R. §1.116

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This RESPONSE C is in reply to the final Office Action dated January 12, 2005. No fee is believed due.

## **Amendments**

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of the claims which begins on Page 2 of this paper.

Remarks begin on Page 12 of this paper.